

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: S. SHIRAYONE, et al.
Application No.: 10/791,856
Filed: MARCH 4, 2004
For: METHOD FOR PROCESSING PLASMA PROCESSING
APPARATUS
Group AU: 1746
Examiner: Zeinab El Arini
Confirm. No.: 5252

SUPPLEMENTAL AMENDMENT

Mail Stop: AMEND – NO FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

June 15, 2007

SIR:

Further in response to the Office Action mailed February 22, 2007, and supplementing the Amendment filed May 22, 2007, please further amend the above-identified application as listed below and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS;

REMARKS are included following the amendments.